

Keyword Index

A. Processing

- Calcination 17, 157, 225, 567, 923, 1979, 2075
Drying 417
Extrusion 837
Film 1089, 1101, 1247, 1257, 1267, 1279, 1505, 1547, 1565, 1603, 1669, 1685, 1741, 1885, 1925
Firing 139, 917, 1017
Grain growth 105, 239, 1161, 2203
Hot pressing 31, 63, 653, 977
Injection molding 579
Injection moulding 991
Joining 823, 1945, 2121
Microwave processing 509, 893, 1635
Milling 745, 1055
Mixing 47, 639, 917
Powder 185, 1873, 1913
Powder: chemical preparation 239
Powder: solid state reaction 1219
Powders: chemical preparation 251, 393, 613, 619, 639, 715, 875, 977, 1231, 1241, 1917, 2235, 2259
Powders: solid state reaction 301, 333, 381, 389, 751, 1225, 1383, 1431, 1597, 2183, 2277
Precursor 469, 751
Pressing 177
Shaping 411, 461, 813
Sintering 1, 87, 105, 177, 285, 301, 343, 381, 401, 417, 419, 429, 539, 571, 579, 643, 689, 721, 807, 813, 869, 883, 893, 911, 953, 1041, 1067, 1181, 1187, 1203, 1427, 1647, 1719, 2117, 2129, 2147, 2163, 2295
Slip casting 139, 205, 745
Sol–gel process 63, 257, 369, 447, 453, 817, 837, 1253, 1263, 1279, 1411, 1477, 1487, 1525, 1547, 1703, 1741, 1749, 1979, 2029, 2087
Suspensions 291, 411, 503, 745, 793, 1049, 2215, 2259
Tape casting 151, 417, 503, 1863, 2099

B. Structure and Microstructure

- Composites 31, 63, 199, 257, 639, 697, 765, 773, 843, 853, 911, 931, 977, 1041, 1271, 1313, 1741, 1787, 1793, 2011, 2105, 2157, 2177, 2269
Defect 1195, 1335, 1341, 1383, 2087, 2241
Electron microscopy 435, 525, 1231, 1529, 1669, 2163
Failure analysis 1619
Grain boundaries 9, 267, 635
Grain size 405, 635, 1895, 2087, 2235
Impurities 291
Inclusions 333
Interface 213, 823, 1257, 1267, 1275, 2215
Microstructure 9, 75, 205, 229, 429, 477, 667, 947, 1009, 1155, 1215, 1237, 1283, 1895, 2011, 2111, 2117
Microstructure-final 689, 911, 931, 953, 977, 1023, 1591, 1597, 1647, 1945, 2171
Nanocomposites 333, 401, 545, 555, 619, 883, 1241, 1499, 1879, 1935
Porosity 69, 251, 343, 597, 745, 817, 1843
Spectroscopy 1, 31, 307, 469, 1435
Surface 291, 865
X-ray methods 145, 285, 389, 393, 447, 469, 545, 555, 625, 751, 869, 1003, 1017, 1187, 1435, 1443, 1635, 2099, 2235

C. Properties

- Chemical properties 139, 1031, 2215
Colour 1, 875
Corrosion 267, 279, 773, 865
Dielectric properties 17, 87, 157, 307, 405, 477, 567, 585, 605, 715, 751, 1003, 1017, 1073, 1085, 1101, 1181, 1187, 1195, 1199, 1207, 1219, 1225, 1237, 1241, 1267, 1271, 1279, 1283, 1325, 1369, 1373, 1377, 1383, 1427, 1435, 1453, 1459, 1487, 1499, 1517, 1521, 1525, 1535, 1553, 1699, 1749, 1780, 1895, 2015, 2037, 2177, 2183, 2283
Diffusion 1275
Electric properties 1263
Electrical conductivity 273, 1253, 1295, 1427, 1435, 1459, 1505, 2105, 2259
Electrical properties 9, 429, 447, 525, 765, 1009, 1101, 1301, 1411, 1493, 1499, 1547, 1557, 1585, 1591, 1623, 1647, 1843, 1921, 1945, 2183
Fatigue 1553
Ferroelectric properties 1169, 1411, 1427, 1449, 1459, 1505, 1553, 1565
Fracture 213, 539, 635, 697, 2081
Friction 625
Hardness 191, 2081, 2111
Impedance 525, 1307
Ionic conductivity 2087
Lifetime 279, 1101
Magnetic properties 447, 515, 1431, 1623, 1979, 1993, 2191

Mechanical properties 199, 213, 229, 257, 435, 579, 597, 697, 765, 801, 869, 911, 953, 977, 983, 1793, 1945, 2099
 Optical properties 225, 285, 2029
 Piezoelectric properties 605, 1079, 1169, 1369, 1373, 1443, 1449, 1453, 1803, 2075, 2171
 Plasticity 2157
 Strength 145, 411

Superconductivity 1581, 1585, 1591
 Thermal expansion 41, 57, 689, 1023
 Thermal properties 469, 597
 Thermal shock resistance 801
 Toughness 2081
 Toughness and toughening 931, 2269

D. Compositions

Al_2O_3 291, 503, 773, 793, 843, 853, 869, 923, 977, 2081, 2105, 2121, 2157, 2215
 $\beta\text{-Al}_2\text{O}_3$ 525
 Alkali oxides 1031
 Alkaline-earth oxide 1319
 Alumina 807, 837, 1967, 2061
 Apatite 199
 Barium titanate 405, 1283, 1325, 1885, 1985
 BaTiO_3 1169, 1271, 1535, 1719, 1895
 BaTiO_3 and titanates 81, 1275
 BeO 1
 Borides 301, 2229
 Carbides 23, 191, 185, 333, 461, 2229
 Carbon 2111
 Clays 251, 381
 Cordierite 927, 1067
 Ferrites 389, 1615, 1979
 Glass 785, 1023, 1655
 Glass ceramics 301, 477, 1181
 Glass–ceramic 343, 927, 983, 1023, 1749, 1753, 1757, 1767, 1773, 2129
 Lead zirconate titanate (PZT) 1141, 1811
 MgO 571, 911
 Mullite 257, 539, 883, 1313, 1319
 Niobates 613, 2235
 Nitrides 23, 2229
 Oxide superconductors 417, 1257, 1585, 1591, 1597

Perovskites 17, 157, 273, 307, 389, 429, 447, 477, 567, 585, 667, 751, 1035, 1231, 1279, 1357, 1411, 1431, 1459, 1499, 1505, 1517, 1905, 2029, 2163, 2183
 PLZT 1831
 Porcelain 883, 953
 PZT 69, 605, 765, 1079, 1089, 1095, 1169, 1215, 1257, 1353, 1483, 1499, 1517, 1529, 1803, 1807, 1863, 1925, 2171
 SiC 125, 151, 177, 213, 401, 405, 411, 697, 721, 813, 869, 931, 947, 2081
 Si_3N_4 121, 267, 635, 653, 901, 2211
 SiO_2 63, 1241, 1685
 Sialon 229, 745
 Silicate 597, 689, 817
 Silicides 2105
 Silicon oxide 1085
 Spinel 369, 911
 TiO_2 509, 1041, 1121, 1365, 2037, 2177, 2305
 Tantalates 715
 Titania 1967, 1975
 Traditional ceramics 381, 917
 Transition metal oxides 1993
 Zinc oxide 93, 105, 1725
 Zirconia 469, 579, 675, 1055, 1793, 1967
 ZnO 497, 1155, 1301, 1647, 1669
 ZrO_2 23, 239, 333, 571, 619, 639, 843, 853, 923, 1041, 2137, 2157, 2259, 2269

E. Applications

Actuators 1803, 1857
 Batteries 393
 Biomedical applications 139, 199
 Capacitors 17, 157, 567, 1101, 1187, 1271, 1275, 1361, 1411, 1547, 1895, 2177
 Cutting tools 2081, 2229
 Electrode 1089
 Fuel cells 1049, 1635, 2087
 Functional applications 225, 1505
 Hard magnets 1979

Lamp envelopes 2029
 Membranes 1487
 Refractories 47, 801
 Sensors 525, 1121
 Structural 199
 Structural applications 121, 257, 267, 865
 Substrates 1, 661, 1231, 1603
 Thermal application 279, 1031
 Thermistors 1073
 Varistors 9, 105, 1009, 1301, 1307, 1647, 2277

Miscellaneous

Ab initio calculations 1989
 Absorption edge 1715
 AC conductivity 2283
 Activator of sintering 643
 Adhesion strength 661
 Admittance 1307
 Afterburning 705, 733
 Aggregation 2305

Aging 1863
 Ag_2O 1607
 AlN 773, 931, 2099
 $\text{Al}_2\text{O}_3\text{--TiC}$ 1909
 Alumina formers 1899
 Aluminum electrolytic capacitor 1741
 Aluminum nitride 661
 Amorphous materials 239

- Anion surfactant 997
- Anisotropic grain growth 1313, 1319
- Anisotropy 539, 653
- Annealing 1921
- Anodizing 1741
- ANSYS 1847
- Antiferroelectric lead zirconate stannate titanate compounds 1393
- Antiferroelectric–ferroelectric transition 1389
- Aqueous dispersibility 219
- Aqueous gel-casting 2057
- Aqueous peroxotitanate solution 1365
- (B,Si) dopant 1763
- (Ba, Sr)TiO₃ 1085
- Ba_{0.7}Sr_{0.3}TiO₃ film 1525
- Barium aluminosilicate 41
- Barium hexaferrite 1623
- Barium stannate titanate 1397, 1401
- Barium strontium titanate 1749, 2283
- Base metal electrode 1283
- BaTiO₃ 1989
- Ba₂Ti₉O₂₀ ceramics 671
- Beta-spodumene 1059
- Bi-2212 1611
- Bi_{0.5}(Na_{1-x}K_x)_{0.5}TiO₃ 1889
- Bi_{3.25}La_{0.75}Ti₃O₁₂ 1553, 1557
- Bi₄Ge₃O₁₂ crystal 1665
- Bi-layered 1175
- Bilayered composite 1999
- BiNb_(1-x)Sb_xO₄ 1017
- BiNbO₄ ceramics 1195, 1335, 1341
- Bioactivity 1781
- Biocarbon template 947
- Bioglass 351, 1781
- Biomimetics 2011
- Biomorphic ceramics 1971
- Biotemplating 1967, 1971
- Bi₂O₃–ZnO–Ta₂O₅ system 1199
- Bismuth 715
- Bismuth-based ceramics 1203, 1211
- Bismuth titanate 1913, 1917
- Bismuth zinc tantalum 1207, 1780
- Bi₄Ti₃O₁₂ 1463
- Bivalva shell 2011
- BiVO₄ 875
- BLT 1565
- B₂O₃ 2121
- Boehmite 837
- Bond valence 2247
- Borosilicate glass 1787
- BPBO 1089
- BPO 1089
- Brazing 901
- Bricks 829
- Brillouin scattering 1707
- BST 1513, 1741, 1753, 1757, 1767, 1773
- BST thin films 1745
- BSTS thin films 1763
- BSZT thin film 1237
- Buffer layer 1247
- CaAl₄O₇ 57
- CaO additions 721
- Carbon nanotubes (CNTs) 63
- Carbon oxidation 485
- Carbon void 1619
- Carbonaceous clay 829
- Caterpillar furnace 1509
- Cathode 1953
- Cation substitution 1207, 1780
- Cavitation 2157
- CCD 1909
- Ceramic fibre 1939
- Ceramic ink 2259
- Ceramic matrix composites 785
- Ceramic NO_x sensors 1135
- Ceramic nozzles 591
- Ceramics 125, 1003, 1169, 1411, 2011
- Cerium oxide 997
- Chalcogenide glasses 1711
- Characterization 653
- Chelate 1525
- Chemical doping 1581
- Chemical durability 983
- Chemical solution deposition 1357
- Chemical solution deposition (CSD) 1811
- CHF₃ 1513
- Citrate and oxalate coprecipitation 1463
- Clay beds 111
- Coal water slurry 591
- Coated rheological property 125
- Coating 1781
- Colloidal processing 837
- Combined water 133
- Columbite 1035, 1369
- Combustion 705
- Combustion synthesis 121, 1909
- Complex impedance 1135
- 1-3 Composite 1141, 1777, 1827
- Composition optimization 2289
- Compressive strength 133
- Conductance master plot 1631
- Conductivity 1155
- Continuous sintering 533
- Copper thick films 661
- Coprecipitation 807, 1661
- CPLD 2033
- Critical current density 1603
- Critical phenomena-phase transformations 239
- Crystal growth 727, 1575, 1679, 1691
- Crystal structure 1529
- Crystalline orientation 1975
- Crystallinity 1781
- Crystallisation 1067
- Crystallite size 923
- Crystallization 671
- Crystallization kinetics 927
- Cu interlayer 901
- Cubic pyrochlore 2241
- Cubic zirconia 2203
- CuO/V₂O₅ 1203
- Curie temperature 1443
- Current–voltage characteristic 1569

- dc electric field 2015
dc resistivity 1295
Debinding 533
Density 1715
Dielectric 1405, 1835, 1885, 2241
Dielectric behaviors 1389
Dielectric ceramics 1191
Dielectric constant 1493, 1627, 1763, 1767, 1773
Dielectric loss 1493
Dielectric permittivity 1295
Dielectric polarizability 2247
Dielectric relaxation 1397
Dielectric resonator antenna 1211
Differential scanning calorimetry 1731
Diffuse phase transition 585, 1295
Diffusion kinetics 485
Diluent 733
Dilution 705
Dip-coating 1049
Dispersant 219, 1985
Dispersants 2215
Dispersibility 675, 939
Displacement 683
Dolomite 983
Domain morphology 1695
Double layer 1803
DSR 605
DTA 927
Dual outputs 1797
Dual polarization model 1419
Duplex-microstructure 1405
Dynamic scaling 1471
Dynamic strength 75
 Dy_2O_3 1009
Economical and environmental impact 311
Elastic coefficients 1675
Elastic properties 1597
Elastic–plastic response debonding 2251
Elasto-optic coefficients 1675
Electric current heating method 1679
Electric field 1389
Electric poling 1147
Electrical resistivity 1283
Electroceramic materials 1147
Electroceramics 2163
Electrochemical characteristic properties 1953
Electrochemical lithium insertion 393
Electrode barrier 1543
Electrolyte admixtures 171
Electromagnetic properties 1615
Electromechanical coupling coefficient 1863
Electron conductors 1107
Electronegativity 1247
Electronic structure 1989
Electro-optic 1745
Electrophoretic deposition 843, 853, 1975
Ellipsometer 1745
Energy resolution 1665
EPD 683, 1803, 1807
Epitaxial 1247
Erosion wear 591
Ethanol 1127
Experiments design 917
Extinction coefficient 1493
FA-129 901
Fast ion conductors 1107
FeRAM 1089
Ferroelectric 1161, 1175, 1405, 1509, 1695, 1707, 2033
Ferroelectric film 1851
Ferroelectric hysteresis 1471
Ferroelectric materials 1529
Ferroelectric polymers 1147
Ferroelectric thin films 1539, 1543
Ferroelectricity 1003, 1811
Ferroelectricity and antiferroelectricity 1263
FGM 683, 1807
Field induced strain 2033
Filter cathodic vacuum arc 2019
Filtered arc plasma 1921
Filtration 111
Finite element method 1827
Finite element modeling 1847
Flow point 939
Fluorapatite 625
Fluoroapatite 1961
Fluorophlogopite 1059
Focal plane array 1851
Four-point probe 2019
Fracture toughness 653, 2011
FRAM 1565
Free lime 133
Gadolinia-doped ceria 807
Gallium oxide 1679
Gas sensors 1127
Gelation 503
Gelcasting 793, 2061
Geometrical factor 441
Glass transition 1731
Grain orientation 1161
Granulated slag (GS) 133
Granule 461
Green body 823
Grossite 57
Growth condition 1679
Hertz cone crack 2251
 HfO_2 1267
High alumina castable 369
High alumina cement (HAC) 133
High-energy ball milling 1127, 1313
High permittivity 1211
High power density 1797
High-temperature oxidation 1899
High temperatures 485
Highly concentrated suspensions 125
Hot spot 1569
Hydration resistance 2117
Hydrophobic–hydrophilic pattern 1815
Hydrostatic pressure 1699
Hydrothermal 1913
Hydrothermal method 93
Hydrothermal synthesis 727
Hydroxyapatite 1787, 1793, 1961

- Hydroxy hydrogel process 2147
- Hydroxy-hydrogel process 357
- Hysteresis 1939
- Hysteresis dispersion 1471
- Hysteresis loop 2033
- Impedance analysis 1347, 1631
- In situ resistance 2019
- Incinerator fly ash waste 343
- Indentation 2251
- Infiltration 533
- Infrared detector device 1823
- Infrared image 1851
- Ink-jet printing 1885
- Intercalation 1611
- Internal stress 1423
- Kaolin clay waste 983
- Kinetics 105
- La modifier 1393
- (La,Sr)FeO₃ 667
- LaAlO₃–SrTiO₃ ceramics 2067
- LaNiO₃ 1253
- Lanthanum 307
- La₂O₃ 2137
- Large crystals 727
- Lattice constants 57
- Lattice match 2143
- Layered film structure 1831
- Layer thickness ratio 441
- Lead calcium titanate 1477
- Lead deficiency 1377
- Lead free electroceramics 1405
- Lead-free piezoelectric ceramics 1889
- Lead-free solder 1115
- Lead lanthanum titanate 1561
- Lead phosphate glasses 1731
- Lead titanyl zirconyl acetate precursor 453
- Lead zirconate stannate titanate ceramics 1389
- Lead zirconate titanates 1835
- Lead zirconate titanate 1827
- Leakage current 1517, 1521
- LiB₃O₅ (LBO) crystal 1675
- (LiCl)_x(P₂O₅)_{1–x} glass 1715
- LiCoO₂ 1641
- Lime 2117
- Limestone 145
- LiMn₂O₄ powder 1953
- Lithium aluminosilicates 1023
- Lithium ferrites 1347
- Lithium-ion batteries 1641
- Lithium-ion battery 1953
- Ln₂O₃ 1703
- Low expansion ceramics 2147
- Low expansion coefficient 1059
- Low sintering 1219
- Low temperature 1247, 1819
- Low-temperature hydrothermal 997
- Low-temperature sintering 1753, 1757
- Low-toxic monomers 793
- LTCC 1181
- Luminescence 285
- Lu₂O₃ additive 635
- Machinability 1059
- Magnesium diboride 1581, 1603
- Magnetic anisotropy 1975
- Magnetic field effect 1627
- Magnetic flux 1607
- Magnetic suspension 1607
- Magnetoelectric effect 1999
- Magnetostrictive 1999
- Magnetron sputtering 1089
- Magnetron sputtering deposition 1155
- Majority charge carrier reversal 1711
- Manganese oxide 1301, 1307
- Matensite transformation 75
- MCM-41 817
- MD simulation 57
- Measurement 2033
- Mechanical activation 1361
- Mechanochemical activation 2137
- MEDICI 1289
- MEMS 1831
- MEMS applications 1147
- Metal carboxylate 613
- MgAl₂O₄ 893
- Micro parts 991
- Microemulsion 675, 1641
- Micro-patterning 1811
- Microwave 1909
- Microwave ceramics 1329, 1929
- Microwave dielectric properties 1203, 2067
- Microwave-induced combustion 1953
- Microwave properties 1199
- Microwave resonators 1191
- Mist plasma evaporation 1535
- Mixed potential 1135
- Mn doping 1615
- Mo(Si,Al)₂ 1899
- Modified sol–gel method 1949
- Modulus 1655
- Modulus analysis 1631
- Monomorph 683, 1807
- Montmorillonite 251
- Morphology 93
- Morphotropic phase boundary 1707
- MPB 605
- Mullitization 1319
- Multilayer 441
- Multilayer ceramic actuator (MCA) 1863
- Multilayer thin film 1835
- Multi-layered SOI MOSFET 1289
- Multilayered thin film 1263
- Multimodal powder 461
- Nanoceramics 239
- Nanocrystalline 1365, 1935
- Nanocrystalline powders 715, 997
- Nano-domains 1575
- Nanofiber 1121
- Nanomaterials 1121
- Nanoparticles 171, 1641
- Nano-powder 1719
- Nanopowders 1661
- Nano-sized zirconia powder 219

- Nanostructure 1725
 Nano-structured 1127
 Nanostructured materials 405, 1869
 Nb₂O₅ 2037
 Neodymium 1325
 Ni 81
 Nickel removal 111
 NiCuZn 1615
 Niobium nitride 733
 Noncentrosymmetric crystals 2005
 Nonlinear optical susceptibility 2005
 NTC thermistor 1661
 NTCR effect 1073
 Number of layers 441
 One-step calcination method 1373
 Optical band gap 1711, 1715
 Optical fiber array 1115
 Optical packaging 1115
 Ordinary Portland cement (OPC) 133
 Organic matter 829
 Oxidation 773
 Oxide ceramics 2241
 Oxide electrode 1357
 Oxides 1003, 1107
 Oxygen 1127
 Oxygen gas sensors 1819
 Oxygen vacancies 1929
 Oxynitride 965
 Packing 461
 Partial melting 1611
 Particle size distribution 533
 Patterning 1815
 Pb(In_{1/2}Nb_{1/2})O₃ 1035
 Pb(Mg_{1/3}Nb_{2/3})O₃ 1035, 1377
 Pb(Zr,Ti)O₃ 2075
 Pb(Zr_{0.53}Ti_{0.47})O₃ 453
 Pb(Zr_xTi_{1-x})O₃ 1543
 Pb-based complex perovskite 2247
 Pb-doped Bi-2223 1611
 Pb–Ge–Se–Te glasses 1711
 PbTiO₃ 1989
 PbTiO₃ thin film 1493
 Permittivity 1655
 Perovskite structure 1831
 PFN 1627
 pH value 219, 1661
 Phase composition 923
 Phase evolution 1231
 Phase structure 1207, 1377, 1780
 Phase transformation 1443
 Phase transition 1237, 2015, 2023
 Phases 1603
 Phosphate 2005
 Phosphate glasses 1737
 Phosphor 225
 Photoacoustic technique 1711
 Photoluminescence 1155
 Photovoltaic effect 1831
 Piezoceramic thick films 1079
 Piezoceramics 1857
 Piezoelectric constant 1863
 Piezoelectric secondary phase toughening 2269
 Piezoelectric transformer 1797
 Piezoelectrics 1161, 1999
 Pigments 875
 Pine wood 1967
 Planetary mixer 1055
 Plasma process 1869
 Plasma spray coating 351, 2251
 Plasma spraying 597
 Plate-like Bi₄Ti₃O₁₂ 1889
 PLD 1175
 PLT 1561
 PMN–32% PT single crystals 1695
 PMN–PT 1369, 1373, 1539, 1691, 1707, 1939, 2015
 PMN-PT single crystal 1699, 1777
 PMNZT 1449
 Polar materials 1095
 Polar regions freezing 1419
 Polarization 1147
 Poly(acrylic acid-co-maleic acid) 1985
 Polycondensation 453
 Polyethylene glycol 2223
 Polymer 1777
 Polymorphic transformation 509
 Porosity 133
 Porous *n*-BaTiO₃ ceramics 2223
 Porous ceramic 205
 Porous ceramics 947, 1353
 Porous oxide ceramics 1967
 Porous silica film 1847, 1949
 Porous SiO₂ film 1843
 Porous TiO₂-ceramics 1971
 Post heat-treatment 229
 Powder precursor 357
 Pressureless sintering in vacuum 2289
 Pr₆O₁₁ 1009
 Processing additives 837
 PSTT 1905
 PT buffer layer 1517
 PTCR 1569, 2223
 PTCR effect 1073
 PtRhO_y 1543
 Pulse electric current sintering 539
 Pure nitrogen 1325
 Pyrochlore 1219, 1225
 Pyroelectric properties 1453, 1823
 Pyroelectric sensor material 1477
 Pyroelectric thin film IR detector 1847
 Pyrolysis temperature 1521
 PZT powders 453
 PZT thin film 1509
 PZT/polymer composite 69
 PZT/PT 1521
 Quantum dots 1685
 Radiation damage 1665
 Raman scattering 1561, 2023
 Raman spectroscopy 1725
 Rapid heat-treatment process 1509
 RBSC 533
 Reaction-formed silicon carbide 435
 Reaction parameters 311

- Reactive infiltration 947
- Reduction 1685
- Refractive index 1493
- Relaxor 585, 1707
- Relaxor ferroelectric ceramics 1905
- Relaxor ferroelectric material 1035
- Relaxor ferroelectrics 1361, 1419, 1423
- Residual stress 901, 1487
- Resistivity 497, 1325, 1879
- Retention 1565
- Reversible dielectric nonlinearity 1401
- RF magnetron sputtering 1539
- Rheological behavior 151, 1985
- Rheological properties 47
- Rheology 829, 1055, 2305
- RIE 1215, 1513
- Rietveld analysis 1483
- RTGG 1889
- SBN 1175
- SBT 1175
- Scanning electron microscope 1725
- Segregation 461
- Self-assembled monolayer (SAM) 1811
- Self-heating effect 1289
- Self-propagating high-temperature synthesis 2229
- Semiconducting glasses 1737
- Shrinkage 991
- SHS 311, 705, 733, 1909, 2211
- Si particle size 965
- Silica fume (SF) 133
- Silver ion conduction 1655
- Simulation 177, 1289
- Si₃N₄/BN 441
- Single crystal 1627
- Single crystal surfaces 1989
- Sinterability 2203
- Sintered reaction-bonded silicon nitride 965
- Sintering additives 965
- Sintering aid 2067, 2075
- Sintering atmosphere 1329, 1335, 1341, 1929
- Sintering condition 1773
- Slim double hysteresis loop 1393
- Slurries 823
- Slurry 151, 1055, 2061
- SnO₂ 2215
- Sodium hexametaphosphate (SHMP) 643
- Soft optical phonon 2023
- Soldering packaging glass fiber array 1115
- Sol-gel 1493, 1513, 1753, 1757, 1767, 1781, 1835, 1843, 1925, 2143, 2283, 2305
- Sol-gel processing 1971
- Sol-precipitation 171
- Sol viscosity 1949
- Solid electrolytes 1135
- Solid oxide fuel cell 667, 1107
- Solid solutions 2137
- Solid state reaction 31, 185
- Solid-solid interfaces 1107
- Solubility 461
- Solubility limit 807
- Soluble counter-ion 219
- Spark plasma sintering 405, 1793
- Spherical powder 675
- Spin, charge, and orbital ordering 1993
- Spin combustion 733
- Spinel structures 1347
- β-Spodumene 357, 2147
- Spray pyrolysis 2295
- Sr₂Nb₂O₇ 2023
- SrRuO₃ 1357
- SrTiO₃ 1101, 1989
- SrTiO₃-based ceramics 1073
- SrTiO₃ nano-sized powders 1819
- Stability 671
- Stabilized zirconia 1135, 1631
- Streaming potential 939
- Stress-induced phase transition 1423
- Strontium aluminosilicate 41
- Strontium barium niobate 1405
- Strontium titanate 477
- Structure 2005
- Submicron powders 2295
- Sulphate attack 133
- Superconductor 2143
- Surface acoustic wave 1857
- Surface charge 939
- Surface morphology 497
- Surface relaxation 1989
- Surface tension 1815
- Surfactant 2305
- Surge resistors 757
- Synthesis 893, 1873
- Ta-doped 1373
- Ta substitution 1369
- Talc 643
- TaN–Cu 1879
- TCP powder 205
- Temperature coefficient of resonant frequency 2247
- Temperature dependence of resistivity 1569
- Temperature field 1847
- Template 1161
- TEP of oxide glasses 1737
- Texture 619, 1161
- Thermal coefficient of resistivity 1879
- Thermal-insulation layer 1843
- Thermal plasma 515, 2191
- Thermal spray coatings 545, 555
- Thermograms 1731
- Thick films 757
- Thickness 497, 1843
- Thickness shear vibration mode 1797
- Thin film 1049, 1095, 1155, 1175, 1215, 1253, 1357, 1483, 1499, 1513, 1557, 1703, 1811, 2163
- Thin film resistor 1879
- Thin-substrate 2057
- Ti(C, N)-based cermet 2111
- Ti₂AlC 1899
- Tin dioxide 2277
- Tin oxide 1869
- TiN 2211
- TiN thin film 1921
- TiO₂ whisker 1889

- Ti₃SiC₂ 2289
Titanium 351
Titanium nitride 705
Titanium silicides 757
Titanium silicon carbide 1873
Tolerance factor 2247
Toroidal magnet 1607
Transducers 1831
Transient liquid phase bonding 2121
Transition metal oxide glasses 1737
Transmission 497
Transport number 1655
Transverse rupture strength 2111
Tunability 1767, 1773
Ultrasonic motor 1857
Ultrasonic pits 1619
Ultrasonic transducers 1827
Ultrasonic wirebonding transducer 1141
UV-irradiation 1815
Vacuum layer 1823
Q-value 1191
V-Grooved fiber array 1115
Water content 1949
Wear behavior 591
Wet point 939
Wolframite 1035
X7R 1361
X-ray 1627
X-ray diffraction 2289
YbBa₂Cu₃O₇ 2143
YBCO 417
2Y-PSZ/steel composite 75
YSZ 1253
Yttria stabilised zirconia 2295
Yttria-stabilized zirconia 2057
Yttrium-doped lead nickel niobate titanate zirconia 1453
Zeolite 727
Zetapotential 171
Zirconia stabilization 571
ZnCr₂O₄ 1135
ZnFe₂O₄ 1135
(Zn_{1-x}Mg_x) 87
ZnO thin films 2019
ZnSe 1685, 1935
ZPCCD-based varistors 1009
ZPCCY-based ceramics 9
Z3Y 579
ZrSiO₄ 279